

**In the Claims:**

**Claim 1-27 (canceled).**

**Claim 28 (new):** A method comprising steps of:

covering a first area in a dielectric, said dielectric having a first dielectric constant;  
exposing a second area in said dielectric to a dielectric conversion source so as to increase said first dielectric constant of said dielectric in said second area to a second dielectric constant;  
wherein said dielectric conversion source comprises E-beams.

**Claim 29 (new):** A method comprising steps of:

covering a first area in a dielectric, said dielectric having a first dielectric constant;  
exposing a second area in said dielectric to a dielectric conversion source so as to increase said first dielectric constant of said dielectric in said second area to a second dielectric constant;  
wherein said dielectric conversion source comprises I-beams.

**Claim 30 (new):** A method comprising steps of:

covering a first area in a dielectric, said dielectric having a first dielectric constant;  
exposing a second area in said dielectric to a dielectric conversion source so as to increase said first dielectric constant of said dielectric in said second area to a second dielectric constant;  
wherein said dielectric conversion source comprises an amine based chemical.

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**Claim 31 (new):** A method comprising steps of:

- covering a first area in a dielectric, said dielectric having a first dielectric constant;
- exposing a second area in said dielectric to a dielectric conversion source so as to increase said first dielectric constant of said dielectric in said second area to a second dielectric constant;
- wherein said dielectric conversion source comprises oxygen plasma.